

PATENT APPLICATION

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q60118

Kazuyoshi MIZUTANI, et al.

Group Art Unit: 1752

Confirmation No.: 5086

Appln. No.: 09/615,708

Examiner: C. HAMILTON

Filed: July 13, 2000

For: BOTTOM ANTI-REFLECTIVE COATING MATERIAL COMPOSITION AND

METHOD FOR FORMING RESIST PATTERN USING THE SAME

AMENDMENT UNDER 37 C.F.R. § 1.111

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

This Amendment is submitted in response to the Office Action dated November 4, 2003.

A Petition for a one month extension of time is being concurrently filed, making a response due on or before March 4, 2004. Please amend the above-identified application as set forth below:

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